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S/N 10/682,229

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

**TABARA** 

Examiner:

G. Goudreau

Serial No.:

10/682,229

Group Art Unit:

1763

Filed:

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Docket No.:

12844.0045US01

Title:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d): I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on October 12, 2005

## REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that this application be accorded the benefits of Continued Examination in accordance with the provisions of 37 C.F.R. §1.114.

A submission meeting of requirements of 37 C.F.R. 1.111 accompanies this paper; or

Please enter the amendment previously filed on August 15, 2005 but not entered.

Please charge the required filing fee of \$790.00 for a large entity to the Deposit Account No. 50-3478. Please charge any additional fee or credit any overpayment to Deposit Account No. 50-3478.

Respectfully submitted,

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Dated: October 12, 2005

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